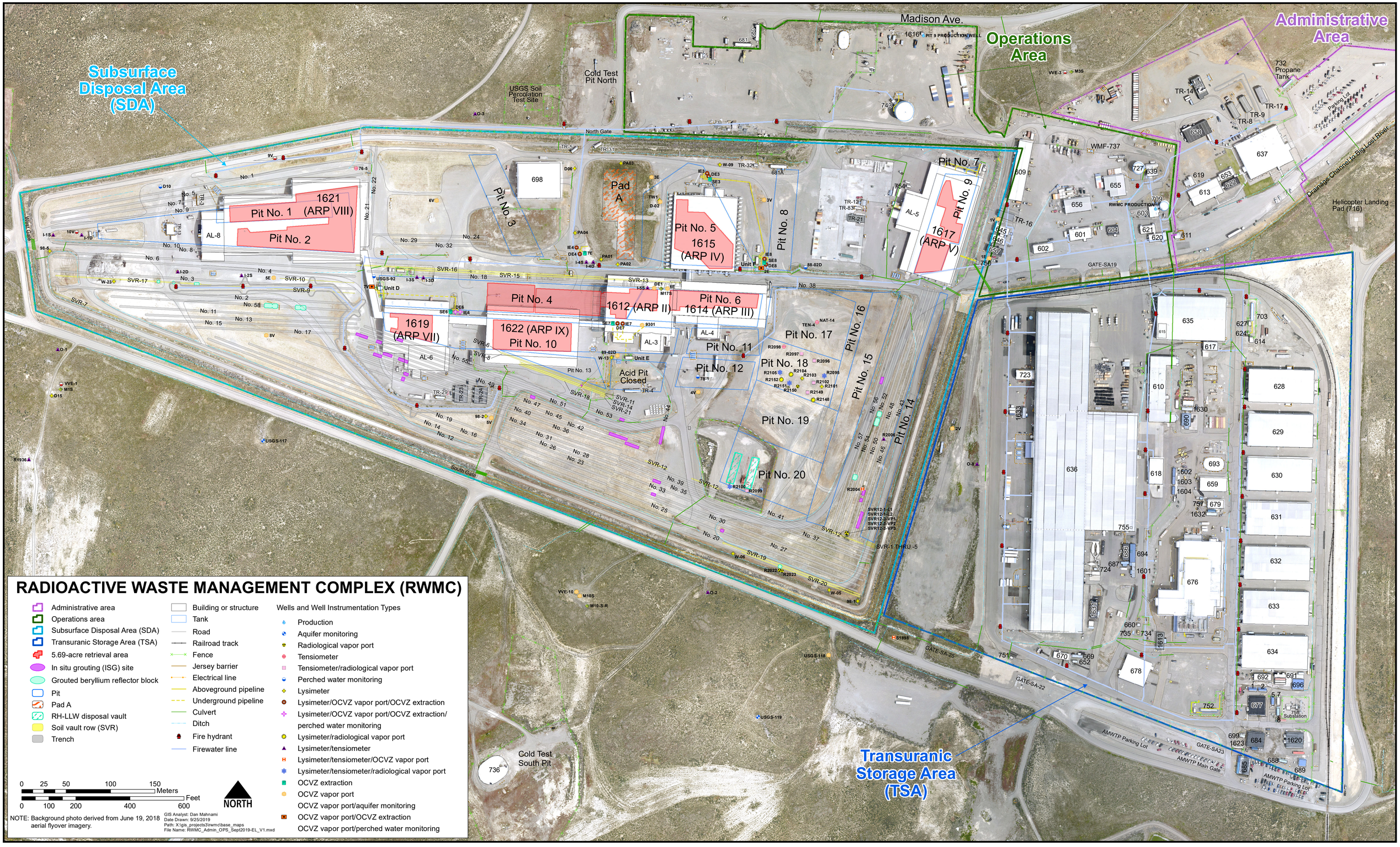
Subsurface Disposal Area (SDA)
Operations Area
Administrative Area
Transuranic Storage Area (TSA)
Madison Ave.
Cold Test Pit North
USGS Soil Percolation Test Site
Cold Test South Pit
Helicopter Landing Pad (716)
Drainage Channel to Big Lost River
Pit No. 1
Pit No. 2
1621 (ARP VIII)
Pit No. 3
Pit No. 4
1619 (ARP VII)
1622 (ARP IX)
Pit No. 10
Pit No. 5
1615 (ARP IV)
Pit No. 6
1614 (ARP III)
1612 (ARP II)
Pit No. 7
Pit No. 8
Pit No. 9
1617 (ARP V)
Pit No. 11
Pit No. 12
Pit No. 13
Pit No. 14
Pit No. 15
Pit No. 16
Pit No. 17
Pit No. 18
Pit No. 19
Pit No. 20
Pad A
Acid Pit Closed
AL-3
AL-4
AL-5
AL-6
AL-8
WMF-737
RWMC PRODUCTION
732 Propane Tank
Parking Lot
North Gate
South Gate
West Gate
GATE-SA19
GATE-SA-25
GATE-SA-22
GATE-SA23
AMWTP Parking Lot
AMWTP Main Gate
758 Substation
SVR-1 THRU -5
RADIOACTIVE WASTE MANAGEMENT COMPLEX (RWMC)
Administrative area
Operations area
Subsurface Disposal Area (SDA)
Transuranic Storage Area (TSA)
5.69-acre retrieval area
In situ grouting (ISG) site
Grouted beryllium reflector block
Pit
Pad A
RH-LLW disposal vault
Soil vault row (SVR)
Trench
Building or structure
Tank
Road
Railroad track
Fence
Jersey barrier
Electrical line
Aboveground pipeline
Underground pipeline
Culvert
Ditch
Fire hydrant
Firewater line
Wells and Well Instrumentation Types
Production
Aquifer monitoring
Radiological vapor port
Tensiometer
Tensiometer/radiological vapor port
Perched water monitoring
Lysimeter
Lysimeter/OCVZ vapor port/OCVZ extraction
Lysimeter/OCVZ vapor port/OCVZ extraction/ perched water monitoring
Lysimeter/radiological vapor port
Lysimeter/tensiometer
Lysimeter/tensiometer/OCVZ vapor port
Lysimeter/tensiometer/radiological vapor port
OCVZ extraction
OCVZ vapor port
OCVZ vapor port/aquifer monitoring
OCVZ vapor port/OCVZ extraction
OCVZ vapor port/perched water monitoring
0 25 50 100 150 Meters
0 100 200 400 600 Feet
NORTH
NOTE: Background photo derived from June 19, 2018 aerial flyover imagery.
GIS Analyst: Dan Mahnami
Date Drawn: 9/25/2019
Path: X:\gis_projects3\rwmc\base_maps
File Name: RWMC_Admin_OPS_Sept2019-EL_V1.mxd